



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Roberto-A
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TECHNOLOGY CENTER 2800

In re Patent Application of

FUKUMI

Atty. Ref.: 829-590

Serial No. 09/993,897

Group: 2812

Filed: November 27, 2001

Examiner: Roman, Angel

For: SEMICONDUCTOR SUBSTRATE AND METHOD FOR FABRICATING THE SAME

* * * * *

December 30, 2002

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT AFTER FINAL

Responsive to the Official Action dated September 30, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

Please substitute the following amended claim(s) for corresponding claim(s) previously presented. A copy of the amended claim(s) showing current revisions is attached.

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1. (Amended) A semiconductor substrate device, comprising:
a first semiconductor substrate including a concave-convex surface;
a second semiconductor substrate having a non-glass thin film insulator on a surface thereof,

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